



# HIGH SENSITIVITY DYNAMIC SENSORS FOR SEMICONDUCTOR MANUFACTURING APPLICATIONS

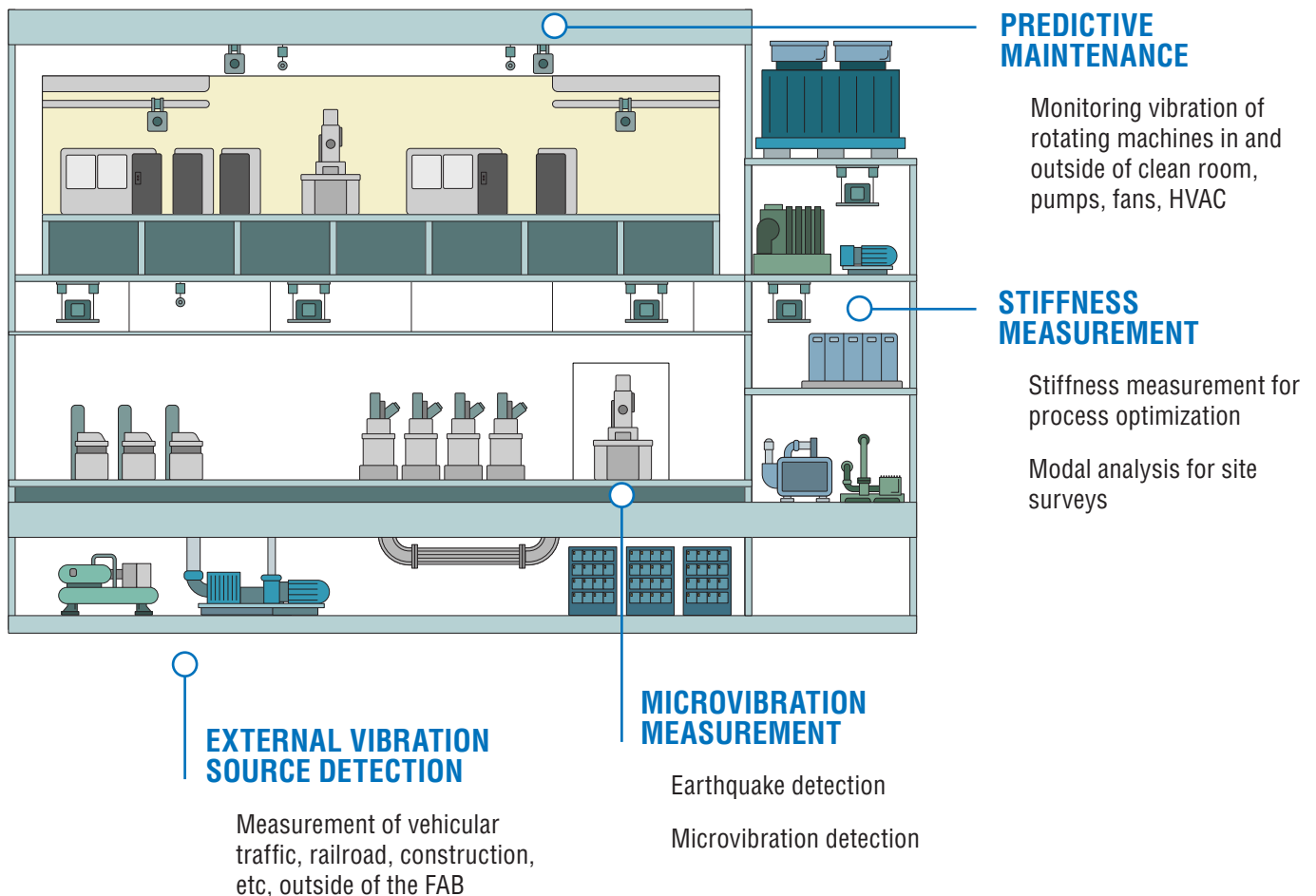
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# HIGH SENSITIVITY DYNAMIC SENSORS FOR SEMICONDUCTOR MANUFACTURING APPLICATIONS

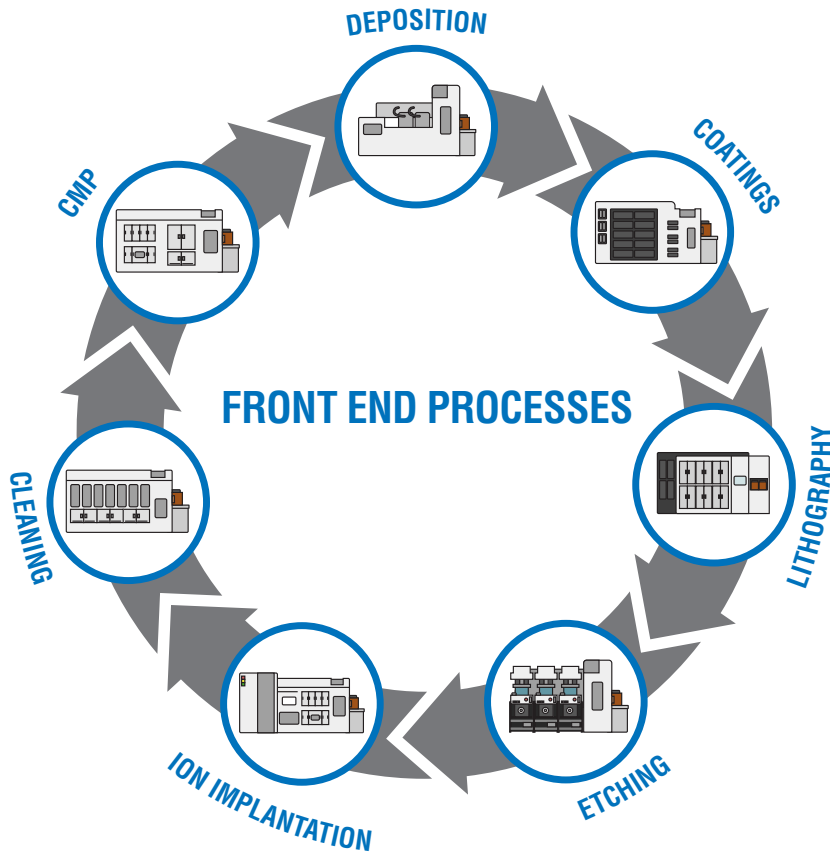
Advanced semiconductor manufacturing processes are extremely complex and rapidly evolving. As consumer demand for smaller sizes and more advanced capabilities continues to grow, it becomes more challenging to avoid manufacturing errors at the nanometer scale. Additional demands for increased throughput require faster-moving manufacturing and inspection machinery, making semiconductors susceptible to higher vibrations during production. These vibrations can corrupt the patterns deposited on the semiconductors, leading to circuit failures in the finished parts.

The patterns on a chip layer are measured in the tens of nanometers, and because the vibrations that can cause manufacturing errors are minuscule (in the millionths of g's), accelerometers typically used for process monitoring simply aren't capable of measuring the tiny deflections that can jeopardize semiconductor quality. Fortunately, high sensitivity accelerometers known for seismic vibration measurement can also detect nanometer-scale deflections, making them a vital tool for advanced semiconductor manufacturing and inspection.

## APPLICATIONS IN THE FAB



## FROM WAFER TO CHIP: WE MEASURE EVERY PROCESS



- **ULTRA-HIGH SENSITIVITY DYNAMIC SENSORS MEASURING:**

Vibration      Pressure  
Force            Acoustics

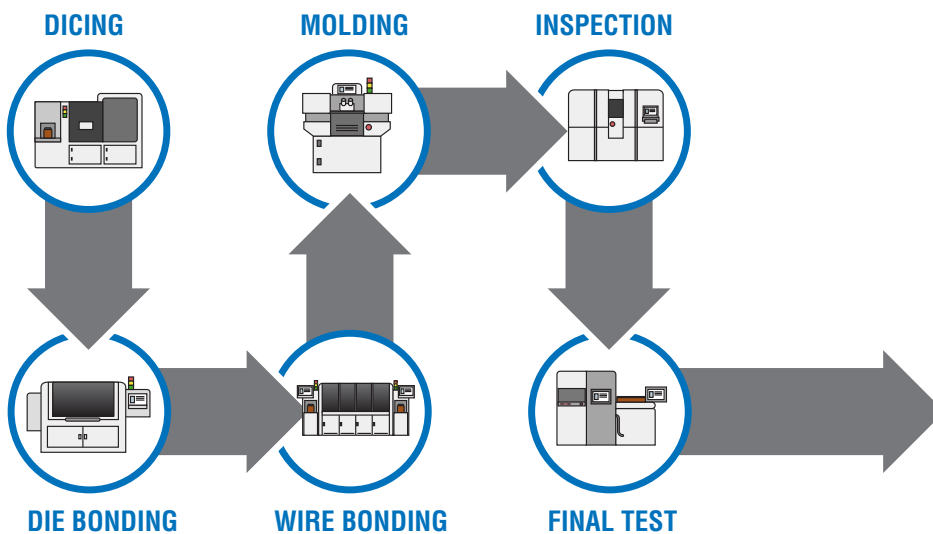
- **LOW OUTGASSING SENSORS, CABLES, AND FEED-THRUS**

- **LOW NOISE SEISMIC ACCELEROMETERS**

- **BROAD ARRAY OF PRODUCTS; WIDE RANGE OF SPECIFICATIONS**

Cryogenic to High Temp  
0 Hz to 60 KHz  
Micro-g to 100,000 g

## BACK END PROCESSES





## ULTRA-HIGH SENSITIVITY, LOW OUTGASSING, LOW NOISE SENSORS FOR:

Deposition  
Lithography  
Etching

Cutting and Packaging  
Metrology and Inspection  
Wafer Transfer and Transport

Our global partnerships with leading data acquisition experts, system integrators, consultants, and engineering firms enable us to provide innovative solutions to the most challenging applications in the semiconductor industry.

Micro-vibration measurement, monitoring, mitigation, and isolation

Condition monitoring for predictive maintenance of critical equipment

Seismic micro-vibration detection and monitoring at advanced fabs

Vibration detection and stiffness verification for site surveys

Modal analysis for vibration phase detection in production equipment and fab structures

Cleaning and decontamination services

Digital connectivity via Ethercat and IO-Link



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TM-SemiConManufacturing-0925